



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

July 3, 2025

IGI Report Number

LG719544919

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

CUT CORNERED RECTANGULAR
MODIFIED BRILLIANT

Measurements

10.11 X 6.73 X 4.34 MM

GRADING RESULTS

Carat Weight

2.60 CARATS

Color Grade

E

Clarity Grade

VVS 2

Cut Grade

EXCELLENT

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

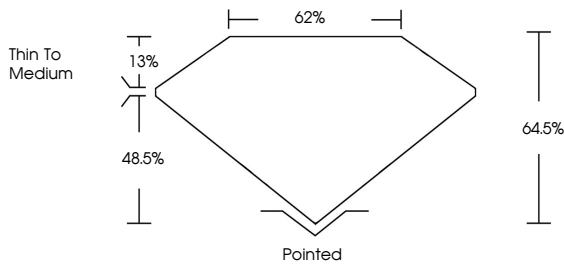
NONE

Inscription(s)

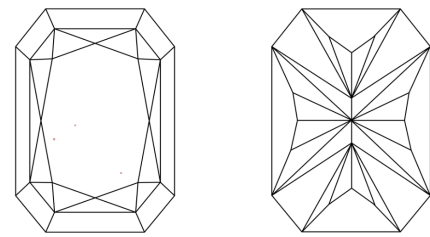
 LG719544919

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS



CLARITY CHARACTERISTICS

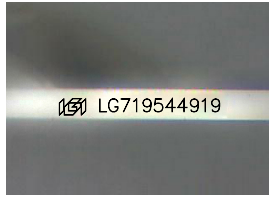


KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

Sample Image Used



COLOR

D E F G H I J

Faint Very Light Light

CLARITY

IF VS 1-2 VS 1-2 SI 1-2 I 1-3

Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



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Carat Weight

2.60 CARATS

Color Grade

E

Clarity Grade

VVS 2

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Polish

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Symmetry

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Fluorescence

NONE

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10.11 X 6.73 X 4.34 MM

Carat Weight

2.60 CARATS

Color Grade

E

Clarity Grade

VVS 2

Cut Grade

EXCELLENT

Depth

64.5%

Table

62%

Girdle

Thin To Medium

Culet

Pointed

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

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